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Substitute for form 1449/PTO		<i>Complete if Known</i>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>			
Sheet	1	of	2
		Application Number	10/685 518
		Filing Date	October 16, 2003
		First Named Inventor	Chul-Sung KIM, et al
		Art Unit	2824
		Examiner Name	C. WILSON
		Attorney Docket Number	239/162 DIV.2

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of 2

**U. S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

Examiner Signature	Christian W. Koen	Date Considered	5/18/04
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Examiner Name	C. WILSON

Sheet 2 of 2 Attorney Docket Number 239/162 DIV.2

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
CSW		WOLF, et al., Silicon Processing for the VLSI Era, Vol 1, Process Technology, Lattice Press, p.201	
		LO, et al, MOS Characteristics of Fluorinated ..., IEEE Electron Device Ltrs, 11(11):511-513, (1990)	
		WRIGHT, et al., Hot-Electron Immunity of SiO <sub>2</sub> Dielectrics with Fluorine.., IEEE, pp. 347-348, (1989)	
CSW		HOOK, et al., Correlation Between Fixed Positive Charge and Hot-Electron., IEEE, pp. 471-473, (1997)	

Examiner Signature	Christa Wilson	Date Considered	5/18/04
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